

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	145002	(develop or developing or developed or development) same (wafer or substrate)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/27 10:11
L2	96	L1 same (dense or supercritical or super adj critical) near2 (fluid or solvent)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/27 10:12
S1	55	(resist or photoresist) near3 develop\$4 same: supercritical: adj (fluid or liquid or solvent)	US-PGPUB; USPAT; DERWENT	OR	ON	2004/11/26 15:01
S2	242	(container or tank or vessel) same supercritical adj (fluid or liquid or solvent) same valve same (regulat\$3 or control\$4 or pump)	US-PGPUB; USPAT; DERWENT	OR	ON	2004/11/26 15:03
S3	162312	develop\$4 same (wafer or substrate or resist or photoresist)	US-PGPUB; USPAT; DERWENT	OR	ON	2004/11/26 15:04
S4	21	S2 and S3	US-PGPUB; USPAT; DERWENT	OR	ON	2004/11/26 15:04
S5	144693	(develop or developing or developed or development) same (wafer or substrate)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 13:25
S6	84	S5 same (supercritical or super adj critical) near2 (fluid or solvent)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/27 10:11
S7	54	temperature near4 (regulat\$3 or control\$5) and S6	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 13:57
S8	34	S7 and valve	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:00
S9	60	S6 and pressur\$5 same gas	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:00
S10	1450	(container or tank or vessel or supply) same supercritical adj (fluid or liquid or solvent)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:18
S11	1803	(container or tank or vessel or supply) same supercritical near2 (fluid or liquid or solvent)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:18
S12	110	(container or tank or vessel or supply) same super adj critical near2 (fluid or liquid or solvent)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:18
S13	1389	(container or tank or vessel) same (supercritical or super adj critical) same (valve or regulat\$3 or control\$4 or pump)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:20

S14	917	(S11 or S12) and S13	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:20
S15	423	S14 and pressur\$5 near3 gas	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:21
S16	310	S15 and temperature near4 (supercritical or super adj critical)	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:23
S17	106	S16 and (wafer or substrate near3 (develop\$3 or manufactur\$3 or process\$3))	US-PGPUB; USPAT; DERWENT	OR	ON	2005/06/21 14:25